

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/085,128 Confirmation No.: 2733

In re Application of:

Kiyoshi ARITA et al. Group Art Unit: 1765

Filed: March 1, 2002 Examiner: Duy Vu Nguyen Deo

For: PLASMA PROCESSING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the U.S. Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Copies of each of the references listed on Form PTO-1449 are attached.

The attached references were cited in a rejection in the counterpart Japanese application. The USPTO is directed thereto for a concise statement of possible relevance of the references cited therein.

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Serial No.: 10/085,128

The above information is presented so that the U.S. Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. See 37 C.F.R. 1.104(a) and 1.106(b) concerning the USPTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

June 22, 2004

Date

Roger W. Parkhurst

Registration No. 25,177

Robert N. Wieland

Registration No. 40,225

RWP:RNW/mhs

Attorney Docket No.: MEIC:122

PARKHURST & WENDEL, L.L.P. 1421 Prince Street, Suite 210 Alexandria, Virginia 22314-2805 Telephone: (703) 739-0220

Sheet 1 of 1									
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)					SERIAL 10/085,1				
			APPLICANT Kiyoshi ARITA et al.				JUN 2 2 2004		
			FILING DATE March 1, 2002			GROUP 1765 TRADEMARK			
U.S. PATENT DOCUMENTS									
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS		SUBCLASS	FILING DATE IF APPROPRIATE		
	6,239,036 B1	05/2001	Arita et al.	438		714	12/1999		
	,								
FOREIGN PATENT DOCUMENTS									
	DOCUMENT NUMBER	DATE	COUNTRY	CLA	\ss	SUBCLASS	TRANSLATION NO YES		
	2000-058521	02/2000	Japan		_			Abstract	
	2000-133639	05/2000	Japan					Abstract	
				<u> </u>					

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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)									
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EXAMINER				DATE C	DATE CONSIDERED				

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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Examiner: Duy Vu Nguyen Deo

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FEE TRANSMITTAL UNDER 37 C.F.R § 1.97(c)(2)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants hereby respectfully request consideration and entry of the Information Disclosure Statement filed contemporaneously herewith. The references were cited in a rejection for the counterpart Japan application. A check in the amount of \$180.00 pursuant to 37 C.F.R. §1.17(p) is also enclosed.

Serial No.: 10/085,128

Consideration and entry of the attached Information Disclosure Statement is respectfully requested.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

June 22, 2004

Date

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In re Application of:

Kiyoshi ARITA et al. Group Art Unit: 1765

Filed: March 1, 2002 Examiner: Duy Vu Nguyen Deo

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CERTIFICATION UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

[x] Each item of information contained in the Information Disclosure Statement filed herewith was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

OR

[] No item of information in the Information Disclosure Statement filed, to my knowledge after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more

Serial No. 10/085,128

than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

PARKHURST & WENDEL, L.L.P.

June 22, 2004

Date

Roger W. Parkhurst

Registration No. 25,177

Robert N. Wieland

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Attorney Docket No.: MEIC:122

Attachment:

Information Disclosure Statement

PARKHURST & WENDEL, L.L.P. 1421 Prince Street, Suite 210 Alexandria, Virginia 22314-2805 Telephone: (703) 739-0220